08/02/04

IFW

Express Mail No.: EV380369617US

Date Mailed: July 30, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

application of: Rong-Chang LIANG, et al.

nong onling and to, or

Appl. No. 10/696,805

Filed: October 29, 2003

For: ELECTROPHORETIC

DISPLAY AND NOVEL PROCESS

FOR ITS MANUFACTURE

Art Unit: 2873

Examiner: Not Yet Assigned

Attorney Docket: 07783.0082.NPUS00

Confirmation No.: 1310

Information Disclosure Statement

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Listed on accompanying Form PTO-1449 are documents that may be considered material to the examination of this application, in compliance with the duty of disclosure requirements of 37 C.F.R. §§ 1.56, 1.97 and 1.98.

Where the publication date of a listed document does not provide a month of publication, the year of publication of the listed document is sufficiently earlier than the effective U.S. filing date and any foreign priority date so that the month of publication is not in issue. Applicants have listed publication dates on the attached PTO-1449 based on information presently available to the undersigned. However, the listed publication dates should not be construed as an admission that the information was actually published on the date indicated.

Applicants reserve the right to establish the patentability of the claimed invention over any of the information provided herewith, and/or to prove that this information may not be prior art, and/or to prove that this information may not be enabling for the teachings purportedly offered.

This statement should not be construed as a representation that a search has been made, or that information more material to the examination of the present patent application does not exist. The Examiner is specifically requested not to rely solely on the material submitted herewith. It is further understood that the Examiner will consider information that had been cited by or submitted

to the U.S. Patent and Trademark Office in a prior application relied on under 35 U.S.C. § 120. 1138 OG 37, 38 (May 19, 1992).

Applicants have checked the appropriate boxes below.

• 1		This	Information	Disclosure	Statement:	is being	filed:
------------	--	------	-------------	------------	------------	----------	--------

- □ a. Within three months of the U.S. filing date of a national application other than a continued prosecution application under §1.53(d);
- □ b. Within three months of the date of entry of the national stage as set forth in §1.491 in an international application;
- c. Before the mailing date of a first Office Action on the merits;
- □ d. Before the mailing of a first Office Action after filing of a request for continued examination under § 1.115.

No statement under 37 C.F.R. § 1.97(e) or fee is required.

or;

- □ 2. This Information Disclosure Statement is being filed after the period specified in paragraph 1(a)-1(d) above, but before the mailing date of a Final Rejection or Notice of Allowance, or action that otherwise closes prosecution in the application, and
 - □ a. I hereby state that each item of information contained in this Information Disclosure

 Statement was first cited in any communication from a foreign patent office
 in a counterpart foreign application not more than three months prior to the
 filing of this Information Disclosure Statement. 37 C.F.R. § 1.97(e)(1), or
 - □ b. I hereby state that no item of information in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to my knowledge after making reasonable inquiry, no item of information contained in this Information Disclosure Statement was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of this Information Disclosure Statement. 37 C.F.R. § 1.97(e)(2), or
 - □ c. Attached is our Check No. _____ in the amount of \$ ____ in payment of the fee under 37 C.F.R. § 1.17(p).

□ 3.	This Information Disclosure Statement is being filed more than three months after the U.S.
	filing date and after the mailing date of a Final Rejection or Notice of Allowance, but
	on or before payment of the Issue Fee. Attached is our Check No in the
	amount of \$ in payment of the fee under 37 C.F.R. § 1.17(i), and
	☐ a. I hereby state that each item of information contained in this Information Disclosure
	Statement was first cited in any communication from a foreign patent office
	in a counterpart foreign application not more than three months prior to the
	filing of this Information Disclosure Statement. 37 C.F.R. § 1.97(e)(1), or
	□ b. I hereby state that no item of information in this Information Disclosure Statement
	was cited in a communication from a foreign patent office in a counterpart
	foreign application, and, to my knowledge after making reasonable inquiry,
	no item of information contained in this Information Disclosure Statement
	was known to any individual designated in 37 C.F.R. § 1.56(c) more than
	three months prior to the filing of this Information Disclosure Statement. 37
	C.F.R. § 1.97(e)(2).
□ 4.	Relevance of the non-English language document(s) is discussed in the present specification.
□ 5.	The document(s) was/were cited in a corresponding foreign application. An English
	language version of the foreign search report is attached for the Examiner's
	information.
□ 6.	A concise explanation of the relevance of the non-English language document(s) appears
	below:
□ 7.	The Examiner's attention is directed to co-pending U.S. Patent Application No,
	filed, which is directed to related technical subject matter. The
	identification of this U.S. Patent Application is not to be construed as a waiver of
	secrecy as to that application now or upon issuance of the present application as a
	patent. The Examiner is respectfully requested to consider the cited application and
_ 0	the art cited therein during examination.
□ 8.	Copies of the documents were cited by or submitted to the Office in Application No.
	, filed, which is relied upon for an earlier filing date under 35
	U.S.C. § 120. Thus, copies of these documents are not attached. 37 C.F.R. § 1.98(d).

It is respectfully requested that the Examiner initial and return a copy of the enclosed PTO-1449, and to indicate in the official file wrapper of this patent application that the documents have been considered.

The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 08-3038 referencing docket number 07783.0082.NPUS00.

Respectfully submitted,

Date: July 30, 2004

Viola T. Kung (Reg. No. 41,131)

HOWREY SIMON ARNOLD & WHITE, LLP

2941 Fairview Park Drive, Box 7 Falls Church, VA 22042

Tel: (650) 463-8181 Fax: (650) 463-8400

INFORMATION DISCLOSURE CITATION

TO-1449

JUL 3 0 2004

ATTY. DOCKET NO. 07783.0082.NPUS00

SERIAL NO.

10/696,805

APPLICANT Rong-Chang Liang

FILING DATE

GROUP

10/29/2003

EX'R INITIAL	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	3,612,758	10-1971	Evans et al			
	3,668,106	06-1972	Ota			
	4,071,430	01-1978	Liebert			
	4,093,534	06-1978	Carter et al			
	4,285,801	08-1981	Chiang			
	4,680,103	07-1987	Solomon I et al			
	5,380,362	01-1995	Schubert			
	5,403,518	04-1995	Schubert			
	5,573,711	11-1996	Hou et al		.,	.,
	5,914,806	06-1999	Gordon II et al			
	5,930,026	07-1999	Jacobson et al			
	5,961,804	10-1999	Jacobson et al			
	6,017,584	01-2000	Albert et al			
	2002/033793	03-2002	Machida et al			
	2002/135861	09-2002	Nakao et al			
	2003/174385	09-2003	Liang et al			
	09/518,488	03-2000	Liang et al			
	09/606,654	06-2000	Liang et al			
	09/759,212	01-2001	Liang et al		·	
	09/784,972	02-2001	Chan-Park et al		7,510	* *
	09/874,391	06-2001	Zang et al			
	09/942,532 (2002-75556)	08-2002 (06-2002)	Liang et al			
	60/315,647	08-2001	Liang et al			
	60/345,934	01-2002	Chen et al			
	60/345,936	01-2002	Chen et al			
	60/356,226	02-2002	Hsu et al			·

							2 01 3	
	60/367,325	03-2002	Ho et al					
	60/375,299	04-2002	Chung et al					
	60/396,680	07-2002	Wu et al					
	60/400,021	07-2002	Yu et al					
	60/408,256	09-2002	Pereira et al					
	60/413,225	09-2002	Chen et al					
· <u>-</u>	60/418,078	10-2002	Yu et al					
		FOREIGN	PATENT DOCUMENT	s				
EX'R INITIAL	PATENT NO.	DATE MM-YYYY	COUNTRY	CLASS	SUBCLASS	YES	NO	
	JP 2003 131270	09-2003	Japan				х	
	WO 02/57843	07-2002	WIPO					
	Int'l Search Report PCT/US03/34562	06-2004	WIPO					
	OTHER DOCUM	ENTS (Includi	ing Author, Title, Date,	Pertinent F	Pages, Etc.)	1.	-	
EX'R INITIAL	DOCUMENT							
	Allen, K. (2003, October). Electrophoretics Fulfilled. Emerging Displays Review: Emerging Display Technologies, Monthly Report Octomber 2003, 9-14.							
	Chen, S.M. (2003, July) The Applications for the Revolutionary Electronic Paper Technology. <i>OPTO News & Letters</i> , 102, 37-41. (in Chinese, English abstract attached, full translation available upon request)							
	Chen, S.M. (2003, May) The New Applications and the Dynamics of Companies. TRI. 1-10. (In Chinese, English abstract attached, full translation availabe upon request)							
	Dalisa, A.L., (1977) Electrophoretic Display Technology. <i>IEEE Trans. Electron Devices</i> , ED-24, 827-834.							
			SiPix Microcup(R) Elec e, English abstract attac				1	
	Roll Manufacturing Pr	ocesses. Pres	cup(R) Electrophoretic a sentation conducted at th ium, Phoenix, Arizona, U	he Flexible	<i>rystal Display</i> Microelectroni	s <i>by Rol</i> cs & Dis	<i>l-to-</i> plays	
			ng, X., Pereira, C., & Che ays by A Roll-to-Roll Ma					
	Liang, R.C., Hou, J., Zang, H.M., Chung, J., & Tseng, S. (2003). Microcup(R) displays: Electronic Paper by Roll-to-Roll Manufacturing Processes. <i>Journal of the SID</i> , 11(4), 621-628.							
	Liang, R.C., Hou, J., Zang, H.M., & Chung, J. (2003, February). Passive Matrix Microcup(R) Electrophoretic Displays. Paper presented at the IDMC, Taipei, Taiwan.							
	Liang, R.C., Hou, J., & Zang, H.M. (2002, December) Microcup Electrophoretic Displays by Roll-to-Roll Manufacturing Processes. <i>IDW</i> , EP2-2, 1337-1340.							

EXAMINER	: DATE CONSIDERED:
	Zang, H.M., & Liang, R.C. (2003) Microcup Electronic Paper by Roll-to-Roll Manufacturing Processes. <i>The Spectrum</i> , 16(2), 16-21.
	Zang, H.M. (2003, October). <i>Microcup (R) Electronic Paper by Roll-to-Roll Manufacturing Processes</i> . Presentation conducted at the Advisory Board Meeting, Bowling Green State University, Ohio, USA.
	Nikkei Microdevices. (2002, December) Newly-Developed Color Electronic Paper Promises – Unbeatable Production Efficiency. <i>Nikkei Microdevices</i> , 3. (in Japanese, with English translation)
	Murau, P. et al. (1978) The Understanding and Elimination of Some Suspension Instabilities in an Electrophoretic Display. <i>J. Appl. Phys.</i> , 49(9), 4820-4829.
	Hopper, M.A. & Novotny, V. (1979). IEEE Trans. Electr. Dev., 26 (8), 1148-1152.
	Liang, R.C., & Tseng, S. (2003, February). <i>Microcup(R) LCD, An New Type of Dispersed LCD by A Roll-to-Roll Manufacturing Process</i> . Paper presented at the IDMC, Taipei, Taiwan.

EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to

applicant.

*If an asterisk is placed beside the reference number, a copy is not provided because the reference was previously cited by or submitted to the PTO in a prior application that is identical in the statement and relied upon for an earlier filing date under 35 U.S.C. §120. 37 C.F.R. §1.98 (d).